



PATENTS

✓ 2826  
\$1

THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: VON AMMON ET AL 9  
SERIAL NO.: 09/813,240 EXAMINER: J. MONDT  
FILED: MARCH 20, 2001 GROUP: 2826  
TITLE: SEMICONDUCTOR WAFER MADE FROM SILICON AND  
METHOD FOR PRODUCING THE SEMICONDUCTOR WAFERS

PETITION UNDER RULE 136(a) AND RULE 17(a)(3)

MAIL STOP FEE AMENDMENT  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

Dear Sir:

Applicant petitions the Commissioner of Patents and Trademarks to extend the time for response to the Office Action dated November 20, 2003, for three months from FEBRUARY 20, 2004, to MAY 20, 2004. A check in the amount of \$950.00, covering the fee for a three-month extension for a Large Entity is enclosed herewith. Any deficiency or overpayment should be charged or credited to deposit Account No. 03-2468.

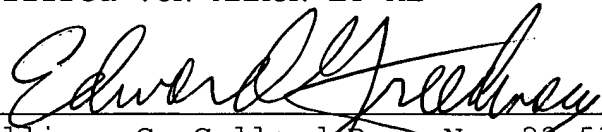
05/24/2004 STEUHEL1 00000034 09813240

01 FC:1253

950.00 DP

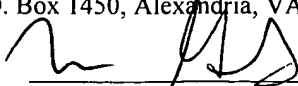
COLLARD & ROE, P.C.  
1077 Northern Boulevard  
Roslyn, New York 11576  
(516) 365-9802

Respectfully submitted,  
Wilfred VON AMMON ET AL

  
Allison C. Collard; Reg. No. 22,532  
Edward R. Freedman; Reg. No. 26,048  
Frederick J. Dorchak; Reg. No. 29,298  
Attorneys for Applicants

Enclosure: Check in the amount of \$950.00

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on May 19, 2004.

  
Maria Guastella